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TO: Examiner: SPEER, Timothy M. Art Unit 1775	COMPANY: U.S. Patent and Trademark Office
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From: Christopher W. Brody

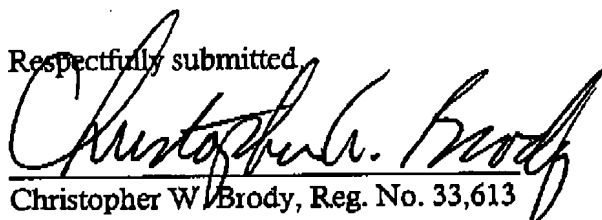
Date: April 16, 2007

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CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the attached **Amendment Under 37 CFR 1.116** for U.S. Serial No. **10/809,712** is being facsimile-transmitted to the U.S. Patent and Trademark Office on the date shown below.

Respectfully submitted,



Christopher W. Brody, Reg. No. 33,613

Date: April 16, 2007

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In re Application of:

Hideshi NISHIKAWA et al.

Serial No.: 10/809,712

Filed: March 26, 2004

Art Unit: 1775

Examiner: Speer, T.

For: SILICON ANNEALED WAFER AND SILICON EPITAXIAL WAFER

AMENDMENT UNDER 37 C.F.R. 1.116

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the outstanding Office Action dated January 16, 2007, please amend the application as follows: